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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 09/787,743 06/08/2001 PAT 6,686,274  
 which is a 371 of PCT/JP99/05108 09/20/1999

YES

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 10-267695 09/22/1998

YES

IF REQUIRED, FOREIGN FILING LICENSE  
 GRANTED

\*\* 04/26/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

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## TITLE

Semiconductor device and its production process